信頼性試験成績書

90nm Process Technology Product and Package

Legacy Fujitsu Reliability Engineering Test Report

Wafer Process : Mie Fujitsu
Assembly : Tong Fu

Reliability Test 1

Device Type : MCU 1
Package Type : Plastic LQFP-100 Package

Test Item	Test Condition	Tested Number		Tested Time	Failed Number
High Temperature Operation Life 高温連続動作試験	125 ℃ V_{DD}=Maximum Rating	231 (77x3Lots)	(a)	1000h	0
Temperature Humidity Bias 高湿連続動作試験	85 ℃ / 85% RH V_{DD}=Maximum Rating	138 (46x3Lots)	(a)	1000h	0
Low Temperature Operation Life 低温連続動作試験	-55℃ V_{DD}=Maximum Rating	78 (26x3Lots)	(a)	1000h	0
High Temperature Storage 高温保存試験	150 ℃	231 (77x3Lots)	(a)	1000h	0
Temperature Cycling 温度サイクル	-65℃～150℃	231 (77x3Lots)	(a)	500cyc	0
Pressure Cooker Test	130℃, 85%RH: 2.33E5 Pa	231 (77x3Lots)	(a)	96h	0
Pressure Cooker Test with Bias	130℃, 85%RH: 2.33E5 Pa V_{DD}=Maximum Rating	99 (33x3Lots)	(a)	96h	0

(a) Pre-condition:

Baking (125℃, 24h) +Moisture Absorption (30℃/70%RH, 192h) +Reflow 260℃ Max x3

Reliability Test 2

Device Type : MCU 2
Package Type : Plastic LQFP-120 Package

Test Item	Test Condition	Tested Number		Tested Time	Failed Number
High Temperature Storage 高温保存試験	150 ℃	77	(b)	1000h	0
Temperature Cycling 温度サイクル	-65℃～150℃	77	(b)	500cyc	0
Pressure Cooker Test	110℃, 85%RH: 1.20E5 Pa	77	(b)	264h	0

(b) Pre-condition:

Baking (125℃, 24h) +Moisture Absorption (30℃/70%RH, 192h) +Reflow 260℃ Max x3

Reliability Test 3

Device Type : MCU 3
Package Type : Plastic QFP-100 Package

Test Item	Test Condition	Tested Number		Tested Time	Failed Number
High Temperature Storage 高温保存試験	150 ℃	77	(c)	504h	0
Temperature Cycling 温度サイクル	-65℃～150℃	77	(c)	500cyc	0
Pressure Cooker Test	121℃, 100%RH: 2.03E5 Pa	26	(c)	96h	0

(c) Pre-condition:

Baking (125℃, 24h) +Moisture Absorption (30℃/70%RH, 48h) +Reflow 245℃ Max.

Reliability Test 4

Device Type : **MCU 4**
Package Type : **Plastic QFN-64 Package**

Test Item	Test Condition	Tested Number		Tested Time	Failed Number
High Temperature Storage 高温保存試験	**150 ℃**	**78**	**(d)**	**1000h**	**0**
Temperature Cycling 温度サイクル	**-65℃～150℃**	**78**	**(d)**	**200cyc**	**0**
Pressure Cooker Test	**121℃, 100%RH: 2.03E5 Pa**	**78**	**(d)**	**168h**	**0**

(d) Pre-condition:

Baking (125℃, 24h) +Moisture Absorption (30℃/70%RH, 192h) +Reflow 260℃ Max. x3

Endurance + Data Retention Test

Device Type : **MCU**
Package Type : **Plastic LQFP-100 Package**

Test Condition (Ta)	Tested Number	Failed Number
10Kcyc (105℃) + **Data Retention Bake : 672h (150℃)**	**117 (3Lots)**	**0**
10Kcyc (105℃) + **HTOL : 1000h (125℃)**	**114 (3Lots)**	**0**

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Rev.	ECN No.	Orig. of Change	Description of Change
**	5769366	KUMI	Initial release.